Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/765,565	LEE ET AL.	
Examiner	Art Unit	
Chuck Huynh	2617	

SEARCHED				
Class	Subclass	Date	Examiner	
455	414.1	7/27/2006	W	

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
			L		

	SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR	
STIC for Korean Patent and Translation	7/27/2006	at	
Class/Subclass: 455/414.1	7/27/2006	W	